NewView™ Accessories

Product guide for the NewView 3D Surface Profiler
OMP-0466



zygo®

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NewView Product Overview

NewView 5000 Standard Series



Typical measurement applications include: precision surfaces, machined parts, advanced materials, MEMS and telecom devices, thick films, coatings, micro-optics, and more.

The NewView provides a broad range of precision measurement solutions. All NewView models provide high-resolution, non-contact, non-destructive, 3D surface measurements.

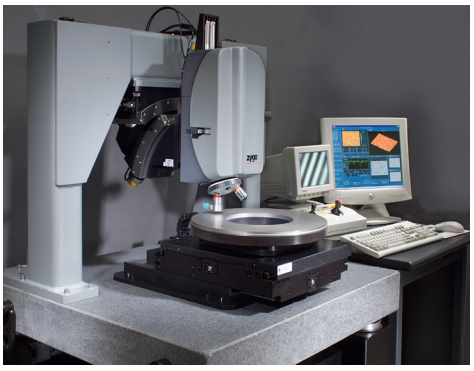
The following models are based on scanning white-light interferometry; these systems offer extreme flexibility to measure a wide variety of surfaces.

Model 5010	Entry-level system provides precise, non-contact 3D surface metrology in an affordable package, with the potential for future upgrading.
Model 5022	A high performance configuration with manual or automated functionality.
Model 5032	Our most advanced system ideally suited for applications requiring highly automated production and process control.

The following models are based on phase-shifting interferometry and are well-suited for measuring relatively flat and smooth surfaces precisely and quickly.

Model 5015	Entry-level cost-effective system.
Model 5035	High performance model, offering increased precision and speed.

LS & CP Series



Typical measurement applications include: wafers, flat panels, automotive parts, machined components, and lapping plates.

The LS and CP series products have similar performance to the NewView model 5032, but can easily accommodate large and heavy samples.

LS 200/300	Capable of automated measurements of large samples. The LS 200 X-Y stage has 200 millimeters of travel; the LS 300 has 300 millimeters.
CP 200/300	Advanced and automated systems suited for wafer-based semiconductor applications. The CP series includes a rotary stage, which accepts a vacuum chuck. The vacuum chuck is optional. The CP 200 X-Y stage has 200 millimeters of travel; the CP 300 has 300 millimeters.

Custom Solutions



Zygo provides application specific metrology solutions using the NewView as the core technology. One example is our large custom-designed flat panel system, which measures large flat panel substrates up to 1 meter square.

For more information on application specific solutions for your business, contact your Zygo Corporation representative.

Objectives Specifications at 1X Zoom

The NewView uses interferometric objectives. The objective creates interference by dividing the light into two paths; directing one to an internal reference surface and the other to the test surface. Surface irregularities in the test part cause the reference and the test wavefronts to travel different distances; when recombined they are out of phase and form an interference pattern.

All objectives are infinite conjugate interferometric objectives. Available objectives: 1X Michelson, 2X Michelson, 2.5X Michelson, 5X Michelson, 10X Mirau, 20X Mirau, 50X Mirau, and 100X Mirau. The 5X, 10X, 20X, and 50X objectives are parfocal.

Long Working Distance (LWD) objectives are useful when measuring into a recessed area, or when you are concerned about crashing into the test part with the objective. LWD objectives mount directly to the microscope with a dovetail adapter; they cannot be mounted on a turret.

Under the Power column, the following abbreviations are used: LW- light weight, LR- low reflectivity (optimized for low reflectivity parts), TC- thermally compensated (maintains focus over wider temperature range), and LWD- long working distance.

Power	Sys Mag	NA	Working Distance (mm)	Focus Depth (µm)	Inter Depth (µm)	Lateral Res (µm)	Field of View H X V (mm)	Spatial Samp (µm) 320x 240	Spatial Samp (µm) 640x 480	Slope (deg)	P/N
1X	20X	0.030	8.5	± 322.5	4.0	11.8	7.0 x 5.3	22.00	11.00	0.79	6300-0204-01
1X LW	20X	0.030	8.5	± 322.5	4.0	11.8	7.0 x 5.3	22.00	11.00	0.79	6300-0204-02
2X LWD	40X	0.055	20.5	± 95.0	4.0	6.43	3.52 x 2.64	11.0	5.50	1.58	6300-0245-01
2.5X	50X	0.075	10.3	± 51.6	4.0	4.72	2.82 x 2.11	8.80	4.40	1.97	6300-0192-01
2.5X LR	50X	0.075	10.3	± 51.6	4.0	4.72	2.82 x 2.11	8.80	4.40	1.97	6300-0192-02
5X	100X	0.130	9.3	± 17.2	4.0	2.72	1.41 x 1.06	4.40	2.20	3.93	6300-0193-01
5X LR	100X	0.130	9.3	± 17.2	4.0	2.72	1.41 x 1.06	4.40	2.20	3.93	6300-0193-02
5X LWD	100X	0.140	20.5	± 14.8	4.0	2.53	1.41 x 1.06	4.40	2.20	3.93	6300-0249-01
10X	200X	0.300	7.4	± 3.2	4.0	1.18	0.70 x 0.53	2.20	1.10	7.73	6300-0194-01
10X LWD	200X	0.280	18.8	± 3.7	4.0	1.26	0.70 x 0.53	2.20	1.10	7.73	6300-0263-01
20X	400X	0.400	4.7	± 1.8	3.6	0.88	0.35 x 0.26	1.10	0.55	14.56	6300-0195-01
50X	1000X	0.550	3.4	± 1.0	2.0	0.64	0.14 x 0.11	0.44	0.22	27.65	6300-0196-01
50X TC	1000X	0.550	3.4	± 1.0	2.0	0.64	0.14 x 0.11	0.44	0.22	27.65	6300-0198-01
100X	2000X	0.800	0.55	± 0.5	1.0	0.45	0.070 x 0.053	0.22	0.11	36.25	6300-0248-01

Specifications at Other Zoom Settings

The NA, Working Distance, Focus Depth, Inter Depth, and Lateral Res specifications are the same at all zoom settings. For other specifications at other zoom settings, multiply the value in the above chart times the multiplier.

Zoom Setting	**0.4**	**0.5**	**0.8**	**1.0**	**1.3**	**2.0**
Multiplier for Sys Mag	0.4	0.5	0.8	1.0	1.3	2.0
Multiplier for Field of View and Spatial Samp	2.5	2.0	1.15	1.0	0.77	0.5

Objective Terminology

Power	Magnifying power of the objective.
Sys Mag	System Magnification, the enlargement of the surface as viewed on the video monitor.
NA	Numerical Aperture, a number representing the resolving power of the objective.
Working Distance	The distance from the end of the objective to the test focus when focused.
Focus Depth	Vertical distance within which any specimen detail will simultaneously be in focus. The coherence bandwidth is centered within the depth of focus.
Inter Depth	Interference Depth, vertical distance over which interference can occur.
Lateral Res	Lateral Resolution, optical resolution of the imaging system.
Field of View	The size of the area imaged and measured.
Spatial Samp	Spatial Sampling, the apparent pixel size, as based on the camera resolution.
Slope	Maximum angle of the surface feature from one pixel to the next that can be measured.
Parfocal	Objectives with a common focus point.

Objective Photos Each objective includes a protective storage case.



1X Michelson Objective
parfocal distance 107.0 mm
Dovetail mount only.



2X LWD Objective
parfocal distance 101.0 mm
Dovetail mount only.



2.5X Michelson Objective
parfocal distance 80.1 mm



5X Michelson Objective
parfocal distance 56.5 mm



10X Mirau Objective
parfocal distance 56.5 mm



20X Mirau Objective
parfocal distance 56.5 mm



50X Mirau Objective
parfocal distance 56.5 mm



50X TC Mirau Objective
parfocal distance 56.5 mm



100X Mirau Objective
parfocal distance 56.4 mm

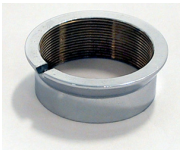
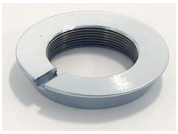
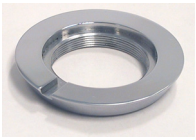
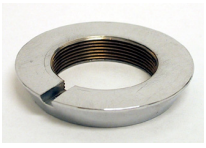
Objective Mount Options

The appropriate adapter to use for a given objective is based on the objective magnification, the NewView model, and whether the objective is mounted in a turret or directly.

The NewView instrument is equipped with a dovetail mount, which accepts either single objectives or a turret mount. The size of this dovetail is different for the 5010 and 5022/5032 models.

Note: The adapters with an asterisk (*) are included as standard items either with the NewView or the objective.

Single Objective Mount (no turret)

NewView Model	1X 2X 5X 10X LWD	2.5X	5X 10X 20X 50X 100X Mirau
5010	Some LWD objectives may include the small dovetail (loosen the 3 setscrews to remove the large dovetail).	 Dovetail Mount*	 Universal Dovetail Mount*
5022/5032	The LWD objectives mount directly using the dovetail mount.	 Dovetail Mount* dovetail part of universal dovetail mount	 Universal Dovetail Mount*  Short Dovetail Mount P/N 6300-1795-01 Provides extra clearance when measuring tall test parts.

Manual Turret Objective Adapters

NewView Model	1X 2X 5X 10X LWD	2.5X	5X 10X 20X 50X 100X Mirau
5022/5032	The LWD objectives cannot be turret mounted.	 Turret Mount Adapter P/N 6300-1824-01	 These objectives mount directly on the turret. Parfocal Kit P/N 6300-1825-01 One required for each objective when used in conjunction with a 2.5X objective.

Motorized Turret Objective Adapters

NewView Model	1X 2X 5X 10X LWD	2.5X	5X 10X 20X 50X 100X Mirau
5022/5032	The LWD objectives cannot be turret mounted.	The 2.5X objective can mount directly on the turret by removing the dovetail.	 Mounting Adapter P/N 1414-100-048 One required for each objective mounted on the motorized turret.  Parfocal Kit P/N 6300-0453-01 One required for each objective when used in conjunction with a 2.5X objective.

Turrets

Manual Turret

The manual turret accepts up to 5 objectives and is rotated into position by the user. The objectives thread into holes in the turret. An adapter is required to mount the 2.5X objective. The 5X, 10X, 20X, 50X, and 100X objectives mount directly into the turret.

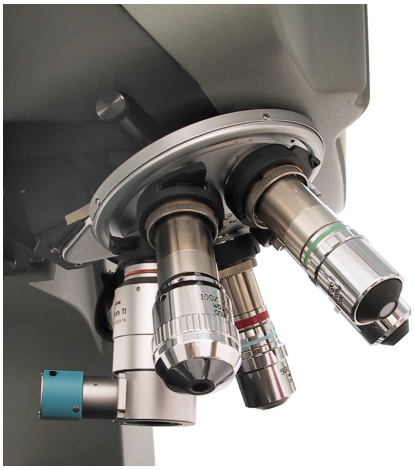


Manual Turret (objectives are not included)

Item	P/N
Manual Turret, fits models 5022/5032	6300-0492-01

Motorized Turret

The automated or motorized turret accepts up to 5 objectives and is automatically rotated into position when the MetroPro Objective button is clicked. The objectives thread into holes in the turret. An adapter is required to mount the 5X, 10X, 20X, 50X, and 100X objectives.



Motorized Turret, objectives other than the 2.5X are shown with parfocal kits (objectives are not included)

Item	P/N
Motorized Turret, fits models 5022/5032	6300-0492-01

Optical Filter Sets

The optical filters are mounted in a filter tray, which slides into the side of the NewView. The NewView comes standard with a MEAS and FOCUS filter. For most applications, these filters acquire good data of the surface under test.

The optional filter sets expand the measurement capabilities by changing the coherence length. The coherence length of an optical source is the maximum path length distance over which interference is obtained. Extending the coherence length can improve the measurement capability for rough surfaces or when measuring surfaces with low contrast or high slopes.

The chart above the photo shows the individual filter specifications and the test part surface roughness for which the filter is applicable. This chart is only a guideline; actual results may vary.

Filter	Bandwidth	Coherence Length	Part Surface Ra
FOCUS	3 nm	N/A	N/A
MEAS	125 nm	2.9 µm	< 3.0 µm
F1	80 nm	4.5 µm	3.0 to 6.0 µm
F2	40 nm	9.0 µm	> 6.0 µm



Standard and Combination 1 Filter Sets are shown

Filter Set	Meas 125 nm	F1 80 nm	F2 40 nm	Focus 3 nm	Comments	P/N
Standard	X			X	Standard, included w 5010/5022/5032.	6300-0487-01
Rough		X	X		Optional, rough surface filters.	6300-0487-02
Combination 1	X		X		Optional, combination set.	6300-0487-03
Std. Phase			X	X	Standard, included w 5015/5035.	6300-0487-04
Combination 2	X	X			Optional, combination set.	6300-0487-05

Stages

Stages hold the part under test and provide for positioning under the objective. Manual and motorized part stages are available. All motorized stages use precision microstepper DC brushless motors.

On the stages shown here, the parcentric point (rotation center) of the lower Tip-Tilt stage is 35.66 mm (1.404 in.) above the X-Y or Y-Theta stage.

The number of axes in a stage listing indicates the total number of *motorized* axes in the system. The NewView measurement head is mounted to a Z stage (focus); standard with all configurations. The Z stage has 102 mm (4 in.) of travel with 0.1 µm (4 µin) resolution.

Basic Z-Axis Pendant

The entry-level, Basic Z-Axis Pendant provides a means to focus and position the measurement head (Z stage). The manual Tip-Tilt and X-Y stage is included.

1-Axis Motorized Z

The 1-Axis Motorized Z configuration is one step up from the Basic Z-Axis Pendant. It provides a Motion Controller to focus and position the measurement head, and supports auto focus and the extended scan option. The manual Tip-Tilt and X-Y stage is included.

Manual Tip-Tilt and X-Y Stage

The manual Tip-Tilt stage has an adjustment range of ±4.2 degrees side-to-side and ±6.0 degrees corner-to-corner. The manual X-Y stage has ± 51 mm (2 in.) of travel.

5-Axis Stage, Motorized Tip-Tilt and X-Y

This stage has a motorized Tip-Tilt parcentric stage and a 2-axis motorized X-Y stage for part positioning. The Tilt stage has an adjustment range of +2/-4 degrees; the Tip stage has a range of ±4 degrees; both with a resolution of 0.04 arc sec. The X-Y stage has 152 mm (6 in.) of travel with 0.1 µm (4 µin) resolution.

5-Axis Stage, Motorized Tip-Tilt and Y-Theta

This stage has a motorized Tip-Tilt parcentric stage and a 2-axis motorized Y-Theta (rotational) stage for part positioning. The Tilt stage has an adjustment range of +2/-4 degrees; the Tip stage has a range of ±4 degrees; both with a resolution of 0.04 arc sec. The Y stage has 152 mm (6 in.) of travel with 0.1 µm (4 µin) resolution. The Theta stage has a resolution of 29 µrad.



Basic Z-Axis Pendant



Motion Controller, included with all motorized stage configurations

Configuration	P/N
1-Axis Motorized Z, Manual Tip-Tilt and X-Y	6300-0160-14
3-Axis Stage, Manual Tip-Tilt, Motorized X-Y	6300-0160-15
5-Axis Stage, Motorized Tip-Tilt and X-Y	6300-0160-16
3-Axis Stage, Manual Tip-Tilt, Motorized Y-Theta	6300-0160-17
5-Axis Stage, Motorized Tip-Tilt and Y-Theta	6300-0160-18
Basic Z-Axis Pendant, Manual Tip-Tilt and X-Y	6300-0160-19

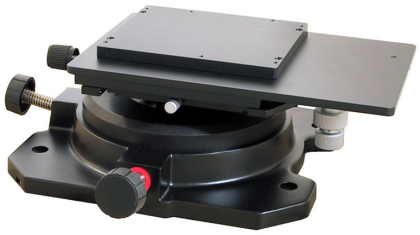
Custom stage options are available; for more information contact your Zygo Corporation representative.

3-Axis Stage, Manual Tip-Tilt, Motorized X-Y

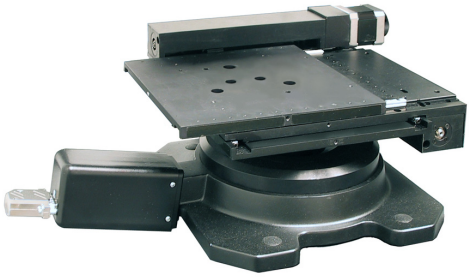
This stage has a manual Tip-Tilt parcentric stage and a 2-axis motorized X-Y stage for part positioning. The manual Tip-Tilt stage has an adjustment range of ±4.2 degrees side-to-side and ±6.0 corner-to-corner. The X-Y stage has 152 mm (6 in.) of travel with 0.1 µm (4 µin) resolution.

3-Axis Stage, Manual Tip-Tilt, Motorized Y-Theta

This stage has a manual Tip-Tilt parcentric stage and a 2-axis motorized Y-Theta (rotational) stage for part positioning. The Y stage has 152 mm (6 in.) of travel with 0.1 µm (4 µin) resolution. The Theta stage has a resolution of 29 µrad.



Manual Tip-Tilt and X-Y Stage



5-Axis Stage, Motorized Tip-Tilt and X-Y



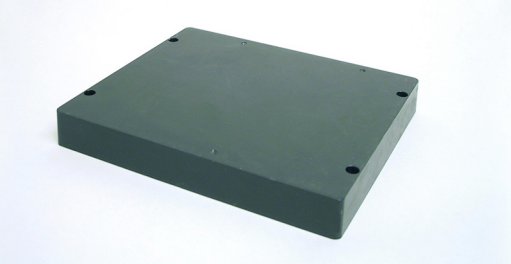
5-Axis Stage, Motorized Tip-Tilt and Y-Theta

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Stage Accessories

General Purpose Top Plates

These plates are used to optimize the height of the sample surface so it coincides at the parcentric point of the tip-tilt stage. This minimizes the X, Y, and Z translation of the part or fixture in the field o f view during the tip/tilt operation. The plates attach with screws to the top of the X-Y stage.
It is recommended to use a plate with all motorized stage configurations.



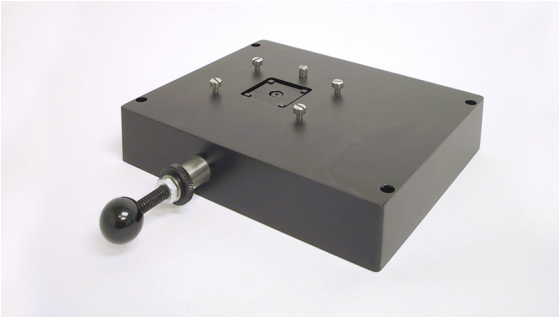
General Purpose Top Plate

Plate Thickness	To Parcentricity*	P/N
1.490 in.	0.012 in.	6300-0130-01
1.030 in.	0.372 in.	6300-0130-02
0.680 in.	0.722 in.	6300-0130-03

* the distance from the top of the plate to the parcentric point of the tip-tilt stage.

Fluoroware Tray Holders

These fixtures are used to hold Fluoroware brand or similar small part trays. The part trays hold small parts during manufacturing and testing, enabling high level automation, repeatability, and ease of use. The holder attaches with screws to the top of the X-Y stage and can be easily removed.



Fluoroware Tray Holder

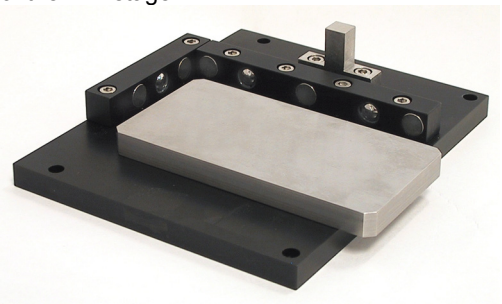
Size - Description	P/N
Holds 2 x 2 Fluoroware Trays	6300-0151-01
Holds 4 x 4 Fluoroware Trays	6300-0151-02

Custom Stage Solutions

Zygo provides custom stage and part fixture solutions to complement the NewView. For more information on custom solutions for your business, contact your Zygo Corporation representative.

Magnetic Interface Fixture

The Magnetic Interface Fixture provides repeatable part registration due to the self-aligning magnets, and includes an integrated reference datum and a metal plate. The metal plate is used to attach part specific holding devices, and is pulled into place by the magnets in the fixture. The universal design can easily accommodate a variety of part-holding fixtures, and enables easy changeover without special tools. The fixture attaches with screws (included) to the top of the X-Y stage.



Magnetic Interface Fixture

Vacuum Chuck

The Vacuum Chuck is for wafer-based applications; it is available in 200 and 300 millimeter diameters. Reference pins on the chuck accommodate wafers with either a notch or a flat. The chuck is slotted for manual wafer loading. A combination of kinematic and magnetic mounting makes installing or removing the chuck easy and repeatable.



Vacuum Chuck

Standards

Lateral Calibration Standard

The Lateral Calibration Standard is used when performing lateral calibration on the NewView to determine the actual dimensions of the pixel-to-pixel spacing of the camera. It is required if you want to use lateral dimensions other than pixels. Calibration is performed manually by the user.



Lateral Calibration Standard

Item	P/N
Lateral Calibration Standard	1670-000-020

Precision Lateral Calibration Standard

This NIST traceable Precision Lateral Calibration Standard is used when performing automatic lateral calibration on the NewView to determine the actual dimensions of the pixel-to-pixel spacing of the camera. This technique is more accurate than using the regular standard, and should be used when precise measurement of lateral dimensions, geometrical dimensions, tilts, and angles are critical. A calibration certificate is provided. Automatic calibration requires MetroPro version 7.6.1 or later.



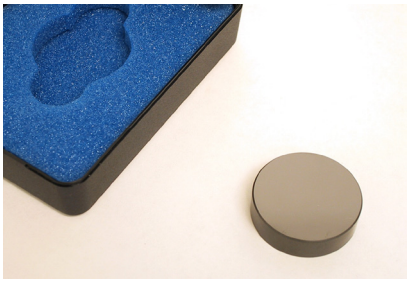
Precision Lateral Calibration Standard

Item	P/N
Precision Lateral Calibration Standard	6300-2198-01

SiC Reference Flat

To achieve the highest precision, it may be required to generate a reference surface of the interferometer's internal optical system. This information can be stored and automatically subtracted from actual surface measurements, thereby minimizing the aberrational effects of the interferometer's optics.

The Silicon Carbide Reference Flat is used to make a system error file, which is used to subtract the internal optical errors of the NewView from the measurements. This optical reference flat is especially important when measuring very smooth surfaces (<3.0 nm Rq).

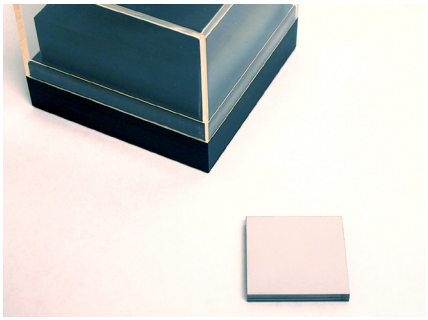


Reference Flat

Item	P/N
SiC Reference Flat	1776-666-012

Step Height Standards

The basic Step Height Standards are NIST traceable and are used to verify the measurement accuracy of the NewView in the z-axis. Select the standard that is closest to the feature height in your part. A calibration certificate is provided with the step height standards. The extended scan gage blocks are used to verify the accuracy of large steps of 1, 5, and 8 millimeters.



Step Height Standard

Item	P/N
Step Height 0.088 µm, nominal	1776-666-009
* Step Height 1.75 µm, nominal	1776-666-010
Step Height 24.0 µm, nominal	1776-666-011
Extended Scan Gage Blocks	6300-0174-01

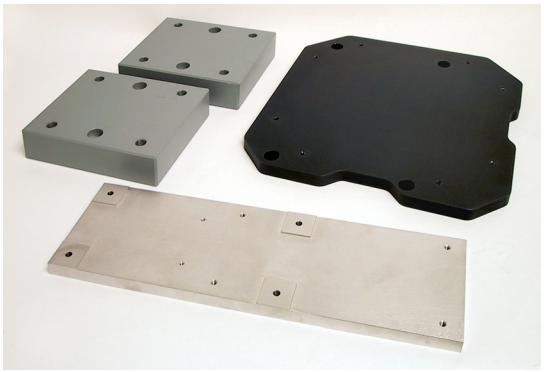
* included as standard with all systems

Other Accessories

Riser Kits

Riser kits are used to raise the height of the NewView to accommodate thicker or taller test parts. A riser kit includes riser blocks for the column and may also include offset mounting plates for the NewView optical head and the stage.

The range of part heights that can be accommodated is determined by the objective in use, how the objective is mounted, and which riser kit is used. The ranges provided in the chart assume the use of the standard stage, which is 5.33 in. (135.4 mm) high.



Sample Riser Kit, shown with column riser blocks, and offset mounting plates for the stage and the Z-axis.

Part Height Range - Riser Kit Selection Chart

	NV Model	No Riser	Riser Kit 01	Riser Kit 02	Riser Kit 03	Riser Kit 04	Riser Kit 05
Height Added by Kit	-	0 in.	1.375 in. (35 mm)	2.500 in. (63.5 mm)	3.875 in. (98 mm)	5.000 in. (127 mm)	6.375 in. (162 mm)
Part Number of Kit	-	-	6300-0454-01	6300-0454-02	6300-0454-03	6300-0454-04	6300-0454-05
Single Objective Mount							
1X	5010	0 - 1.1 in. (0 – 28)	0 - 2.5 in. (0 –64)	0 - 3.6 in. (0 – 92)	1.1 – 5.0 in. (27 – 127)	2.2 - 6.1 in. (55 - 155)	3.6 - 7.5 in. (90 – 190)
2.5X	5010	0 - 2.5 in. (0 – 64)	0 - 3.9 in. (0 – 99)	1.1 - 5.0 in. (27 – 127)	2.4 - 6.4 in. (62 – 162)	3.6 - 7.5 in. (91 – 191)	4.9 - 8.9 in. (126 – 226)
5X, 10X, 20X, 50X, 100X	5010	0 - 3.7 in. (0 – 93)	1.1 - 5.0 in. (28 – 128)	2.2 - 6.2 in. (57 – 157)	3.6 - 7.5 in. (92 – 192)	4.7 - 8.7 in. (120 – 220)	6.1 - 10.0 in. (155 – 255)
2X LWD, 5X LWD, 10X LWD	5010	0 - 1.6 in. (0 – 40)	0 - 2.9 in. (0 – 74)	0.1 - 4.1 in. (3 – 103)	1.5 - 5.4 in. (38 – 138)	2.6 - 6.6 in. (67 – 167)	4.0 - 7.9 in. (101 – 201)
1X	5022/5032	0 - 2.2 in. (0 – 55)	0 - 3.5 in. (0 – 89)	0.7 - 4.7 in. (19 – 119)	2.1 - 6.0 in. (54 – 154)	3.2 - 7.2 in. (82 – 182)	4.6 - 8.5 in. (117 – 217)
2.5X	5022/5032	0 - 3.6 in. (0 – 93)	1.1 - 5.0 in. (28 – 128)	2.2 - 6.1 in. (56 – 156)	3.6 - 7.5 in. (91 – 191)	4.7 - 8.6 in. (120 – 220)	6.1 - 10.0 in. (155 – 255)
5X, 10X, 20X, 50X, 100X	5022/5032	0 - 3.4 in. (0 - 85)	0.8 - 4.7 in. (20 – 120)	1.9 - 5.9 in. (49 – 149)	3.3 - 7.2 in. (84 – 184)	4.4 - 8.4 in. (112 – 212)	5.8 - 9.7 in. (147 – 247)
2X LWD, 5X LWD, 10X LWD	5022/5032	0 - 2.1 in. (0 – 53)	0 - 3.5 in. (0 – 89)	0.7 - 4.6 in. (17 – 117)	2.0 – 6.0 in. (52 – 152)	3.2 - 7.1 in. (80 –180)	4.5 - 8.5 in. (115 – 215)
Manual Turret Mount							
5X, 10X, 20X, 50X 100X	5022/5032	0 - 3.2 in. (0 – 81)	0.6 - 4.6 in. (16 – 116)	1.8 - 5.7 in. (45 – 145)	3.1 - 7.1 in. (80 – 180)	4.3 - 8.2 in. (108 – 208)	5.6 - 9.6 in. (143 – 243)
2.5X and 5X, 10X, 20X, 50X, 100X w/ parfocal kit	5022/5032	0 - 2.0 in. (0 – 50)	0 - 3.3 in. (0 – 85)	0.5 - 4.5 in. (14 – 113)	1.9 - 5.8 in. (48 – 148)	3.0 – 7.0 in. (77 – 177)	4.4 - 8.3 in. (112 – 212)
Motorized Turret Mount							
5X, 10X, 20X, 50X, 100X	5022/5032	0 - 3.1 in. (0 – 78)	0.5 - 4.4 in. (13 – 113)	1.6 - 5.6 in. (42 – 142)	3.0 - 6.9 in. (77 – 177)	4.1 - 8.1 in. (105 – 205)	5.5 - 9.4 in. (140 - 240)
2.5X and 5X, 10X, 20X, 50X, 100X w/ parfocal kit	5022/5032	0 - 2.1 in. (0 – 54)	0 - 3.5 in. (0 – 89)	0.7 - 4.6 in. (18 – 118)	2.1 - 6.0 in. (53 – 153)	3.2 - 7.1 in. (82 – 181)	4.6 - 8.5 in. (116 –216)

Dimensions shown in inches and (millimeters)

Vibration Isolation Table

A Vibration Isolation Table isolates the system from external sources of vibration and is necessary for ultimate system performance. The table for the NewView is specially designed with a counter-weight for maximum dampening effect.



Vibration Isolation Table

Size (HWD)	P/N
31 x 24 x 24 in.	1840-700-105

Worktables

The Worktable provides a working surface conveniently located at the proper height and position next to your NewView instrument. It also provides a lower shelf to hold system electronics.



Worktable, Wrap-around



Worktable, Square

Worktable	Size (HWD)	P/N
Wrap-around	34 x 52 x 35 in.	6300-2080-01
Square	34 x 28 x 35 in.	6300-2130-01

Photographic images are representative only. Specifications and part numbers are subject to change without prior notice.

Zygo Corporation
Laurel Brook Road
P.O. Box 448
Middlefield, CT 06455-0448
U.S.A.

Phone: (860) 347-8506
Customer Support: (800) 994-6669
E-Mail: inquire@zygo.com
Web Site: www.zygo.com

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